



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6/I.D.S

1/15/03

Smith

Applicants: McDonald Robinson et al.

Group Art Unit: 2813

Application No. 10/010,704

Examiner: Timothy J. Sutton

Title: Methods of Using Si-Ge-C in
Selective Etch Applications

Attorney Docket No. Lawrence 712

Filing Date: November 13, 2001

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Examiner Sutton:

This Information Disclosure Statement is submitted:

☐ under 37 CFR 1.97(b), or
(Within three months of filing national application; or date of entry of
international application; or before mailing date of first office action on the
merits; whichever occurs last)

☒ under 37 CFR 1.97(c) together with either a:
☐ Certification under 37 CFR 1.97(e), or
☐ a \$180.00 fee under 37 CFR 1.17(p), or
(After the CFR 1.97(b) time period, but before final action or notice of
allowance, whichever occurs first)

☐ under 37 CFR 1.97(d) together with a:
☐ Certification under 37 CFR 1.97(e), and
☐ a petition under 37 CFR 1.97(d)(2)(ii), and
☐ a \$130.00 petition fee set forth in 37 CFR 1.17(i)(1).
(Filed after final action or notice of allowance, whichever occurs first,
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☒ Applicant(s) submit herewith Form PTO 1449-Information Disclosure Citation
together with copies, of patents, publications or other information of which applicant(s)

are aware, which applicant(s) request be considered in examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

Respectfully submitted,

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231

Date of Deposit: December 26, 2002

Signature: Robert Moll

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